

SUPPLEMENTAL APPLICATION DATA SHEET

APPLICATION INFORMATION

Application Number:: 10/533,810
Application Date:: 05/05/05
Application Type:: REGULAR
Subject Matter:: UTILITY
CD-ROM or CD-R?: NONE
Title:: METHOD OF FORMING FILM ON
SUBSTRATE
Attorney Docket Number:: 271672US2PCT
Total Drawing Sheets:: 6

INVENTOR INFORMATION

Applicant Authority Type:: INVENTOR
Primary Citizenship Country:: Japan
Status:: FULL CAPACITY
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CORRESPONDENCE INFORMATION

Correspondence Customer Number:: 22850

REPRESENTATIVE INFORMATION

Representative Customer Number:: 22850

DOMESTIC PRIORITY INFORMATION

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	National Stage of	PCT/JP03/14188	11/07/03

FOREIGN PRIORITY INFORMATION

Application Number:	Country::	Filing Date::	Priority Claimed::
2002-325000			

Japan	11/08/02	YES
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ASSIGNMENT INFORMATION

Assignee Name:: National Institute of Adv. Industrial Sci. & Tech.
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